



MEMC TP-01-2450 (3009)  
PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Application of: Robert J. Falster, et al. Art Unit: 1765  
Serial No.: 10/615,127  
Filed: July 8, 2003  
Confirmation No.: 8157  
For: PROCESS FOR PREPARING A STABILIZED IDEAL  
OXYGEN PRECIPITATING SILICON WAFER  
Examiner: Felisa C. Hiteshew

May 6, 2005

AMENDMENT A

TO THE COMMISSIONER FOR PATENTS,

SIR:

In response to the Office action mailed January 6, 2005,  
please enter the following amendments and consider the following  
remarks.

Remarks begin on page 2 of this paper.

Conclusion begins on page 4 of this paper.

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